

Supplementary information

**Design and Synthesis of Multifaceted Rhodanine Linked
Thiophene as SnO_x-Perovskite Dual Interface Modifier
Facilitating Enhanced Device Performance Through Improved
Fermi Level Alignment, Defect Passivation and Reduced
Energy Loss**

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Supplementary Figures

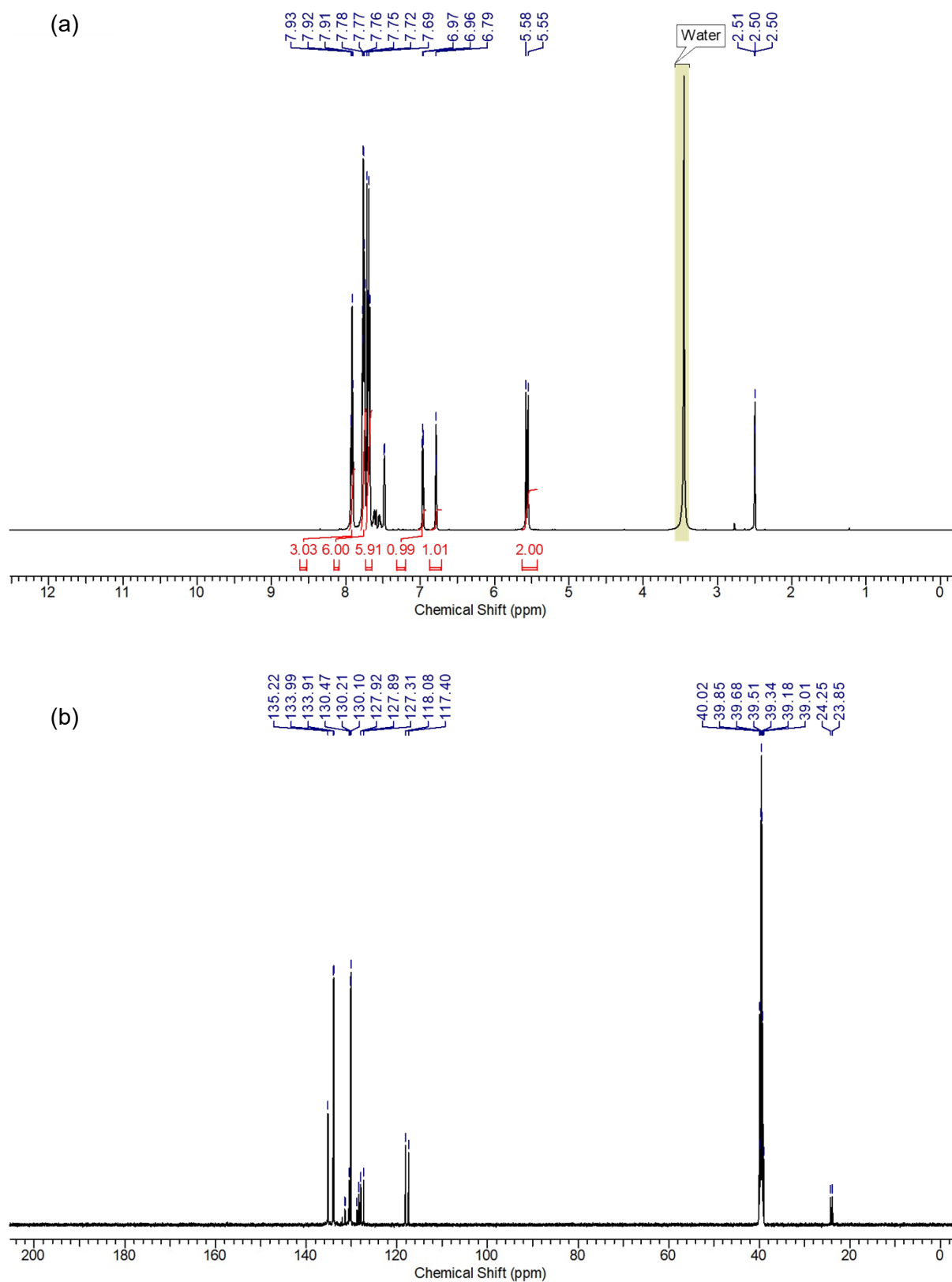


Fig. S1 (a) ^1H -NMR data of the compound **2** and (b) ^{13}C -NMR data of the compound **2**.

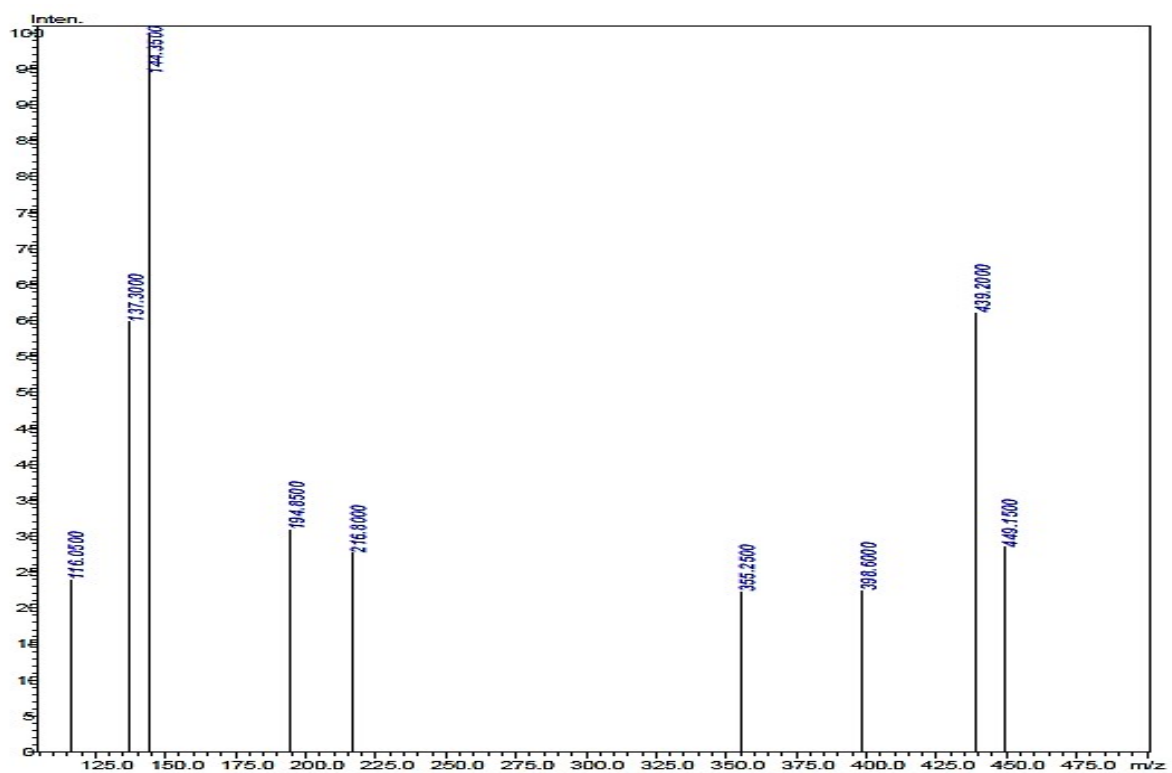


Fig. S2 HPLC-MS data of the compound **2**.

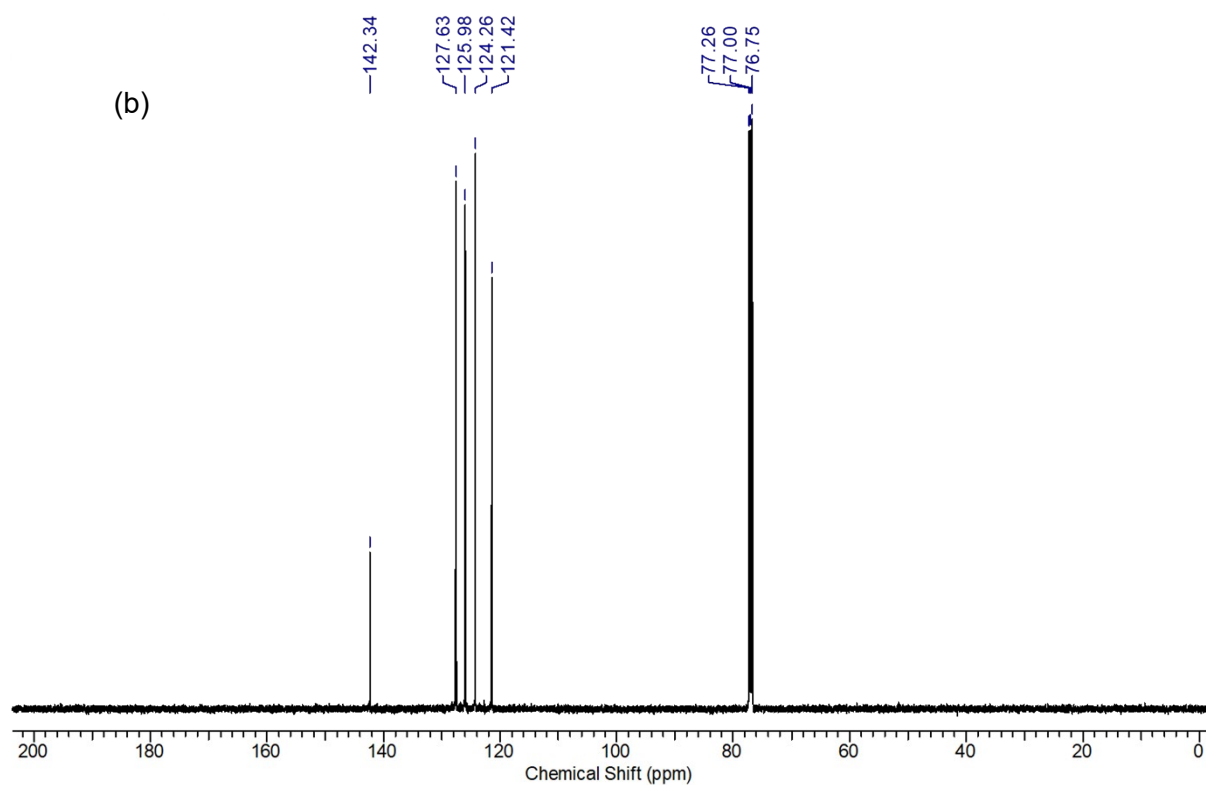
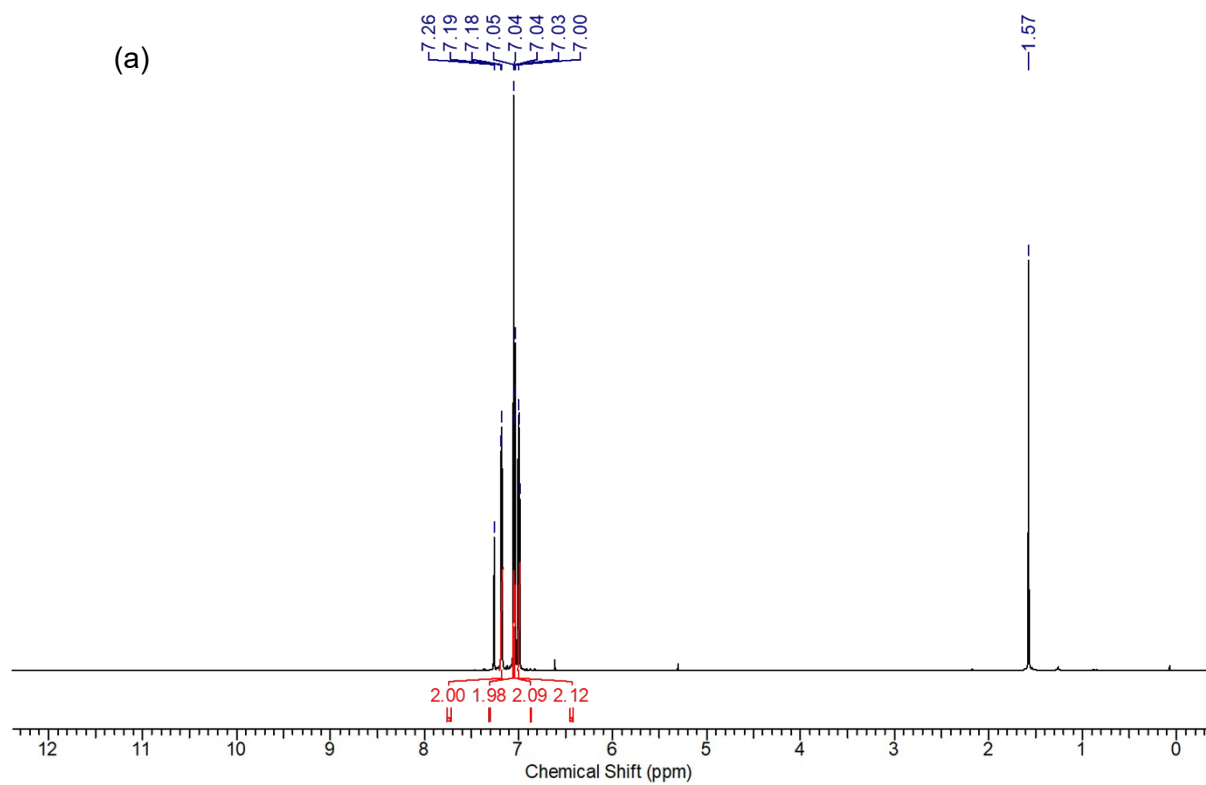


Fig. S3 (a) ^1H -NMR data of the compound **3** and (b) ^{13}C -NMR data of the compound **3**.

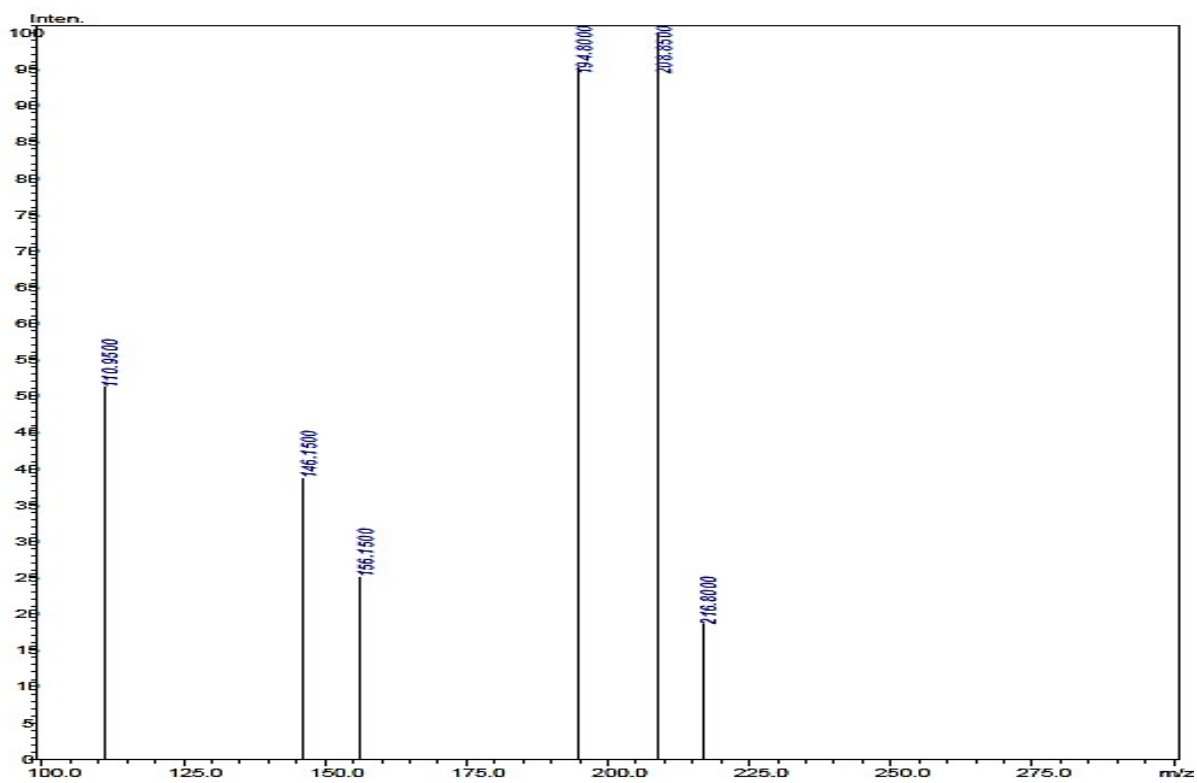


Fig. S4 HPLC-MS data of the compound **3**.

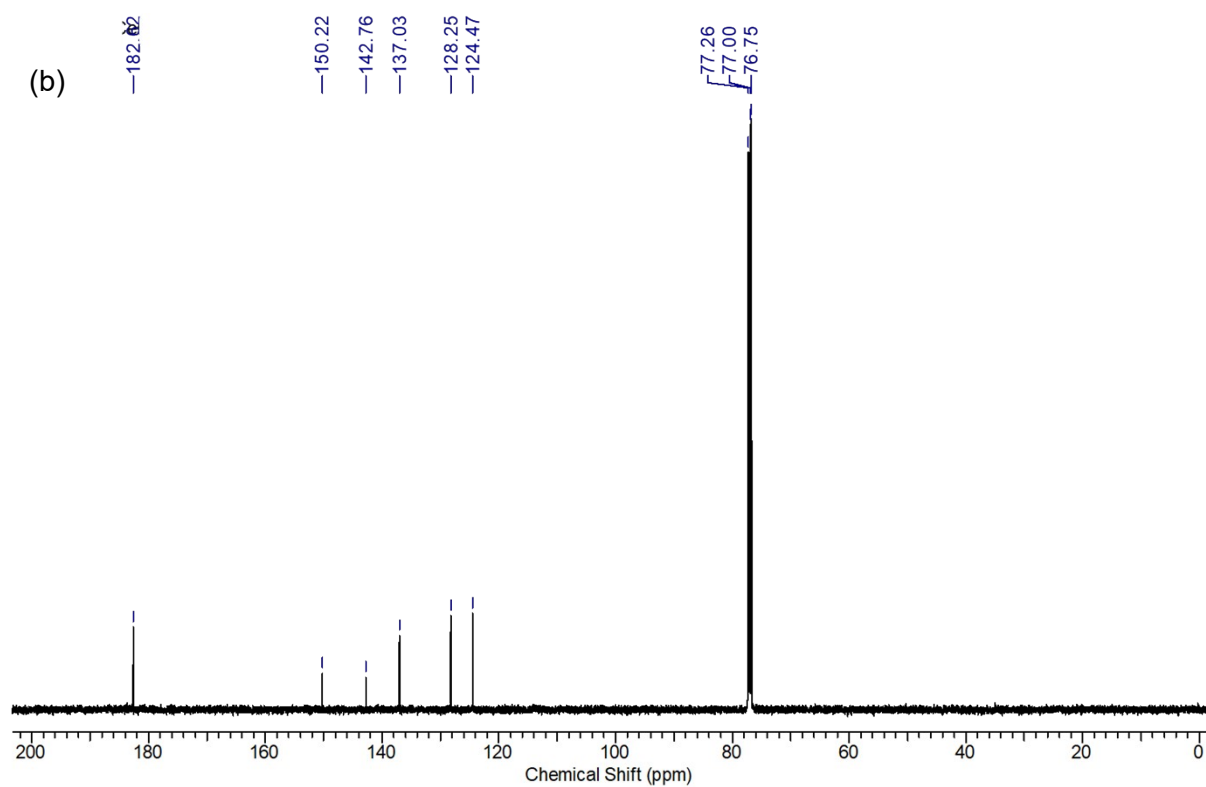
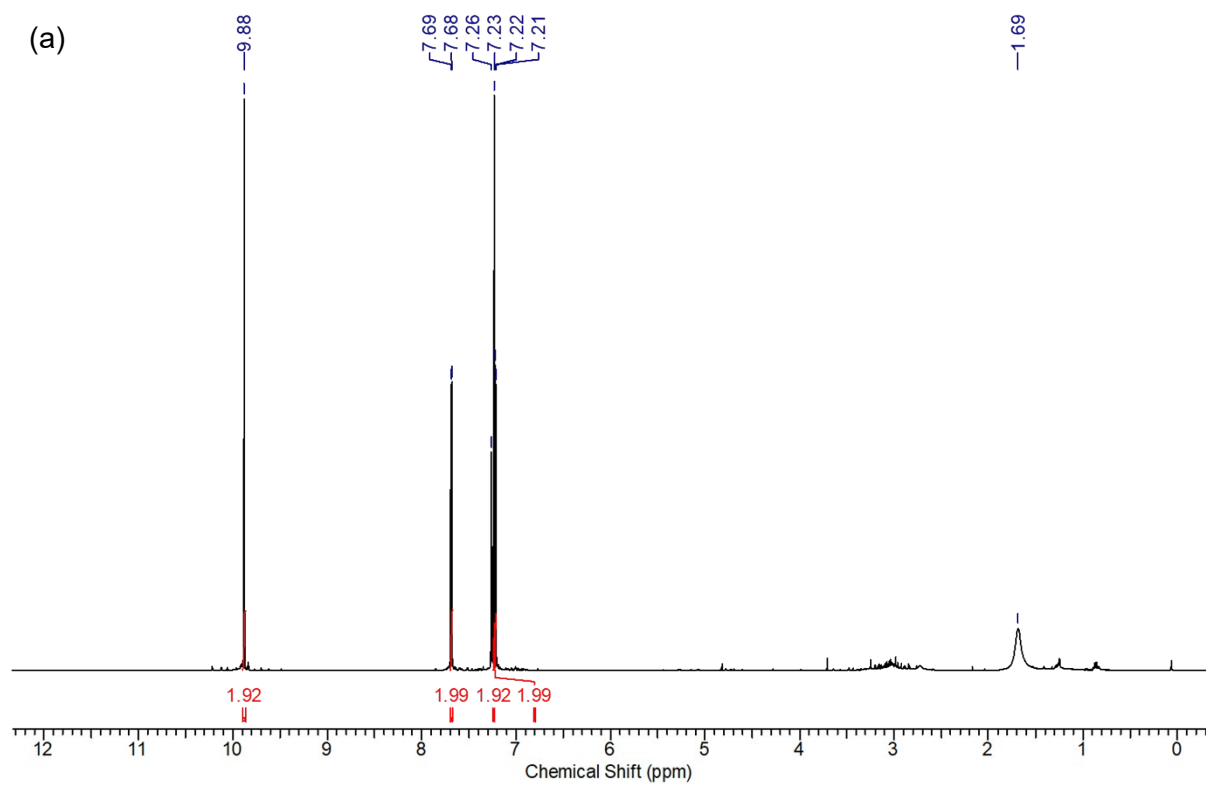


Fig. S5 (a) ^1H -NMR data of the compound **4** and (b) ^{13}C -NMR data of the compound **4**.

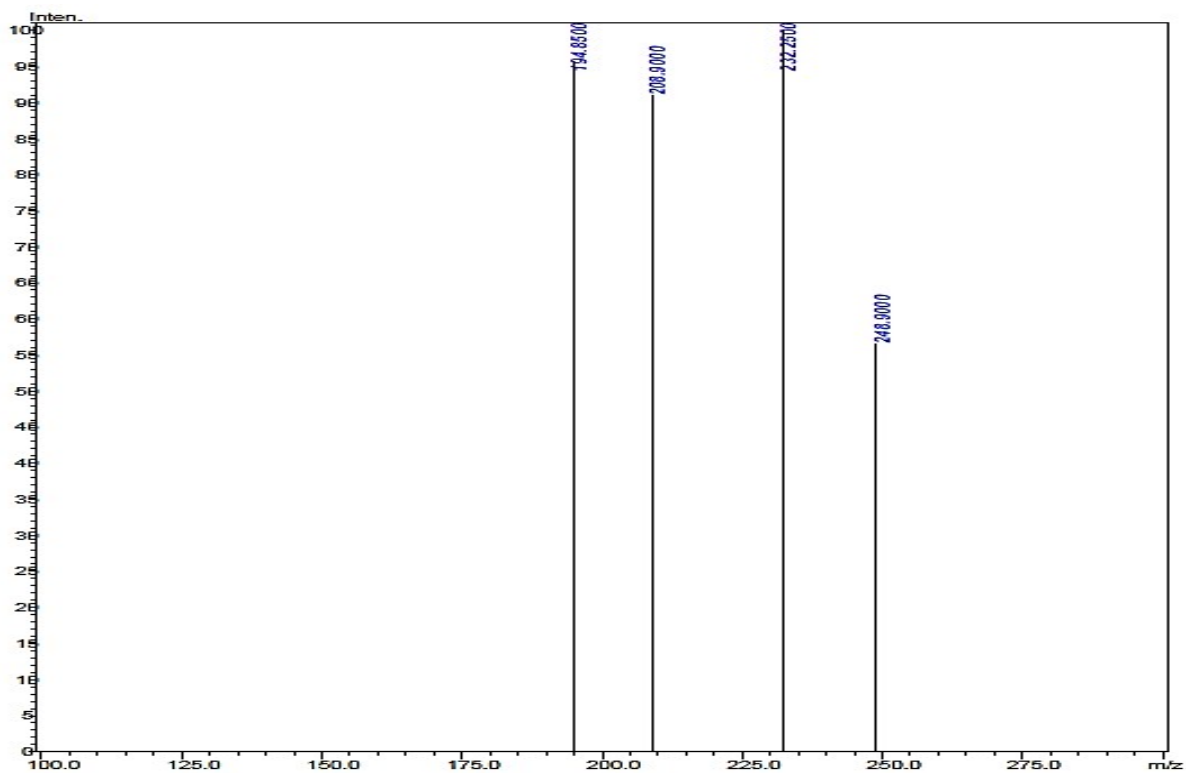


Fig. S6 HPLC-MS data of the compound **4**.

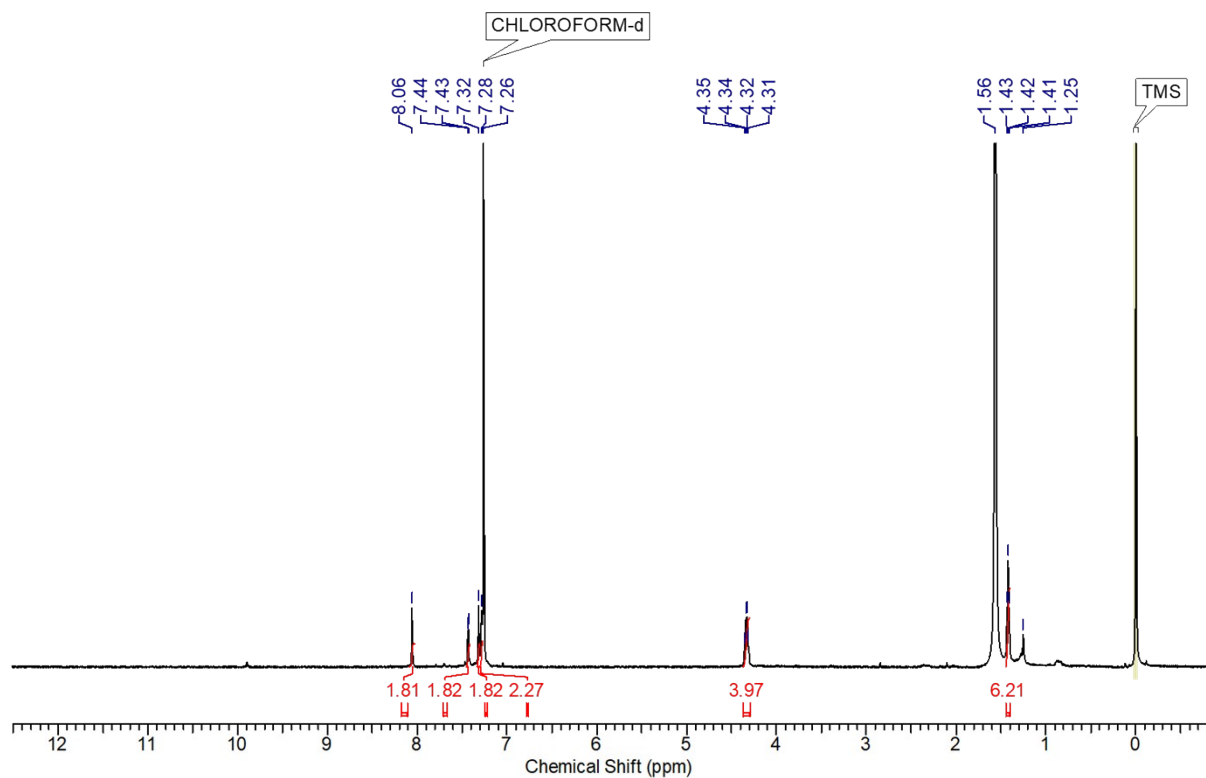


Fig. S7 ¹H-NMR data of the compound **AA6**.

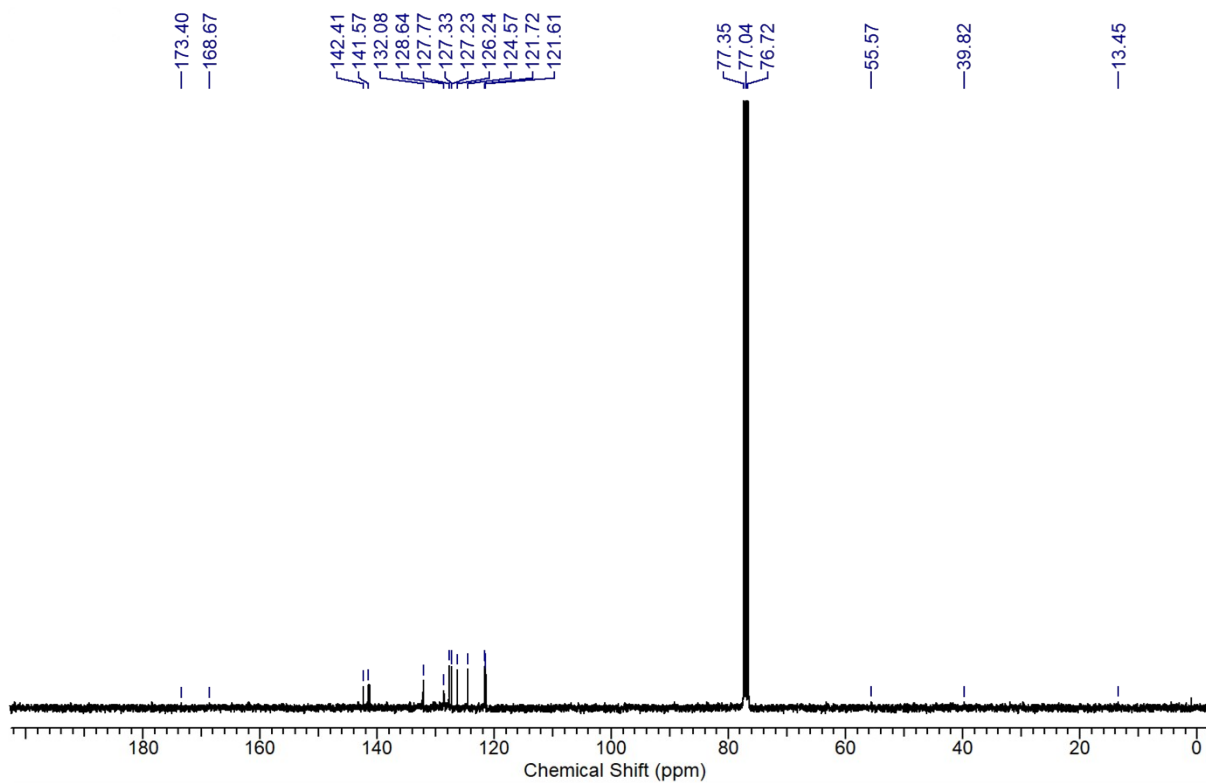


Fig. S8 ^{13}C -NMR data of the compound **AA6**.

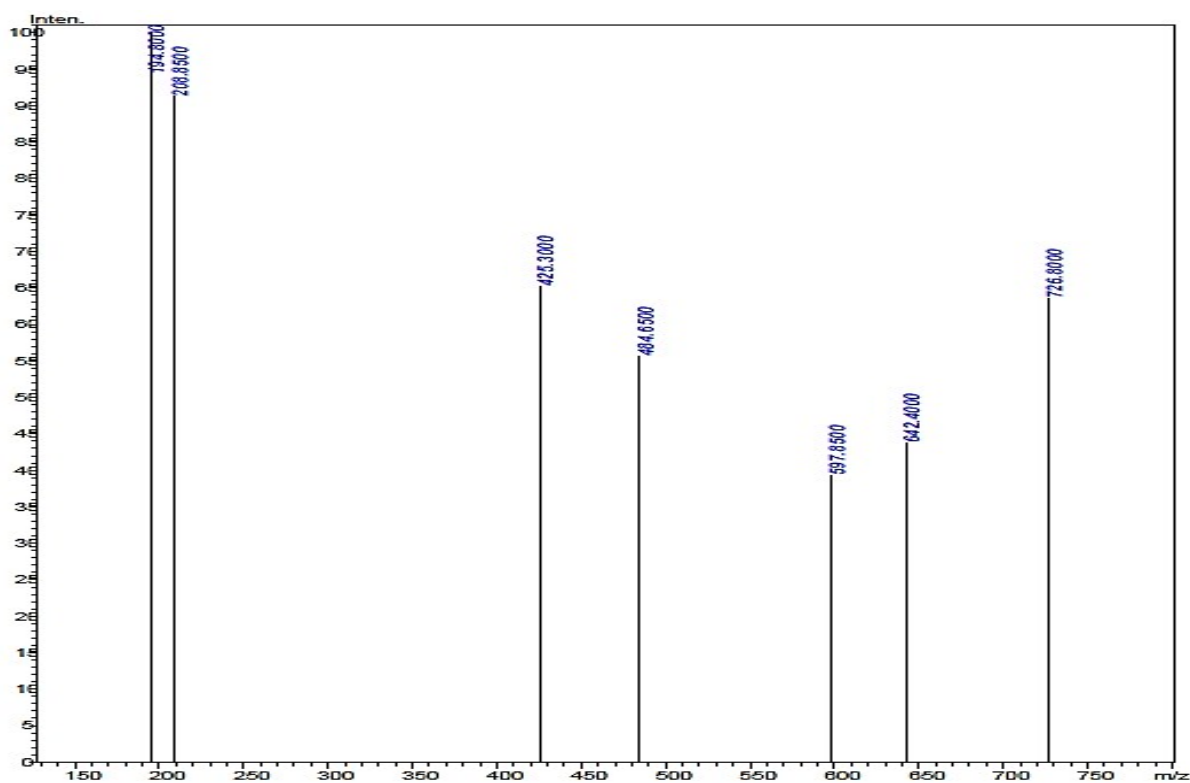


Fig. S9 HPLC-MS data of the compound **AA6**.

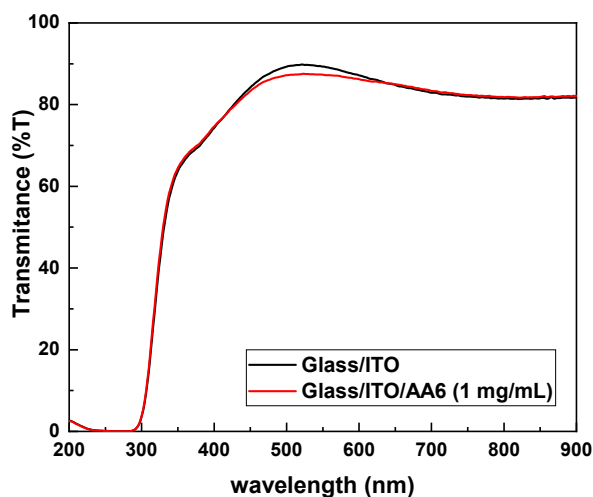


Fig. S10 UV-Vis. %T spectra of AA6 coated on ITO/Glass substrate.

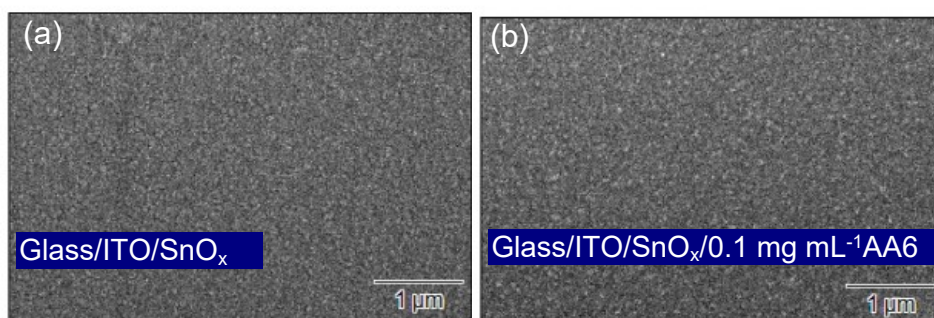


Fig. S11 (a) SEM analysis of SnO_x. (b) AA6 passivated SnO_x thin films.

Table S1 EDX percentage of all possible elements in SnO_x and AA6 passivated SnO_x thin films.

Element	SnO _x	SnO _x /0.05 mg mL ⁻¹	SnO _x / 0.1 mg mL ⁻¹	SnO _x /0.2 mg mL ⁻¹
	wt. %	AA6 wt. %	AA6 wt. %	AA6 wt. %
C	6.89	6.47	6.94	6.15
N	3.29	2.54	0.61	2.14
O	50.24	49.47	51.69	51.65
S	0.02	0.09	0.3	0.41
Sn	39.56	41.45	40.45	39.65
Total	100.00	100.00	100.00	100.00

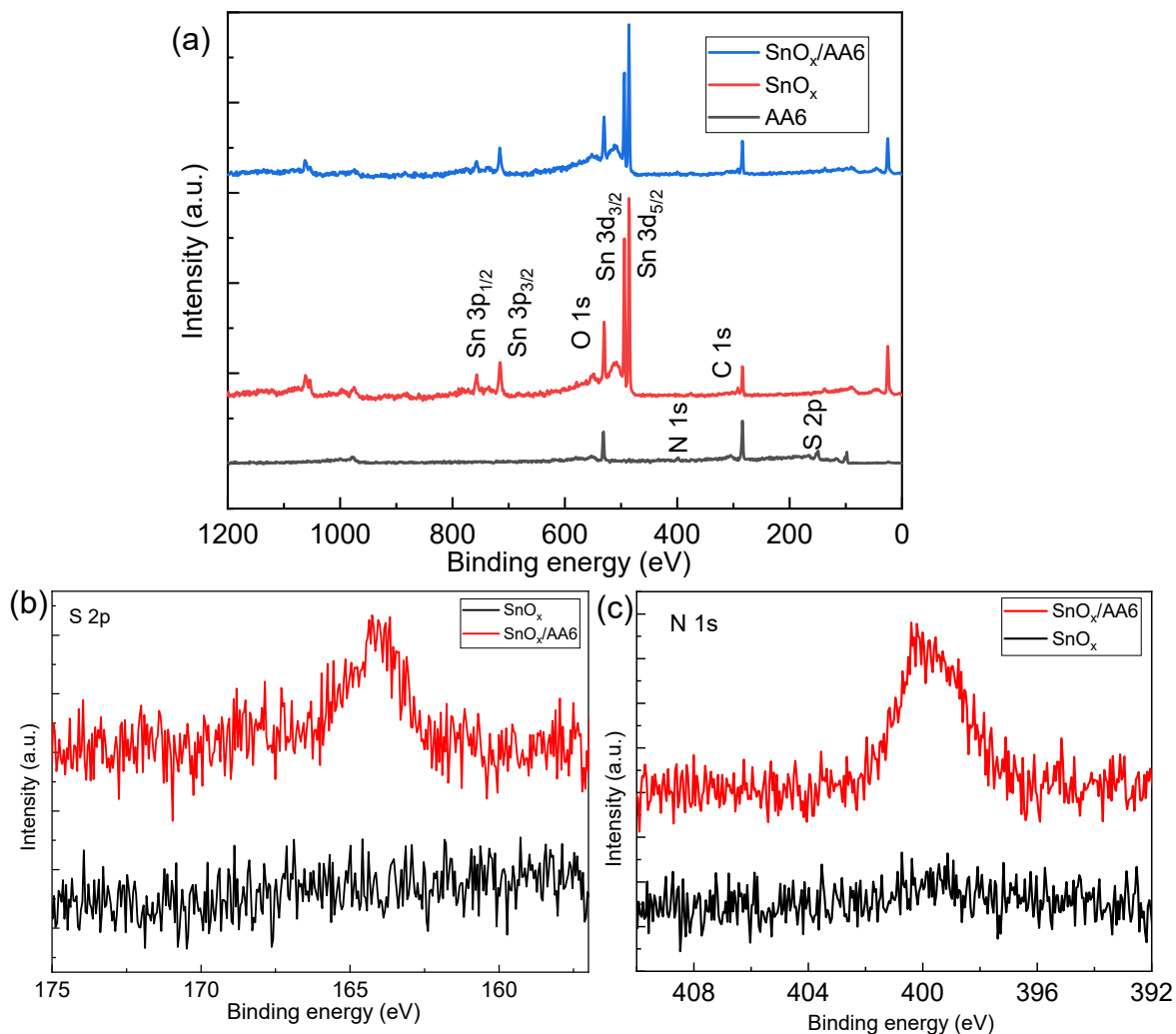


Fig. S12 (a) XPS survey scan of AA6, SnO_x & SnO_x/AA6 thin films. (b) S 2p plots for SnO_x and AA6 passivated SnO_x films. (c) corresponding N1s plot.

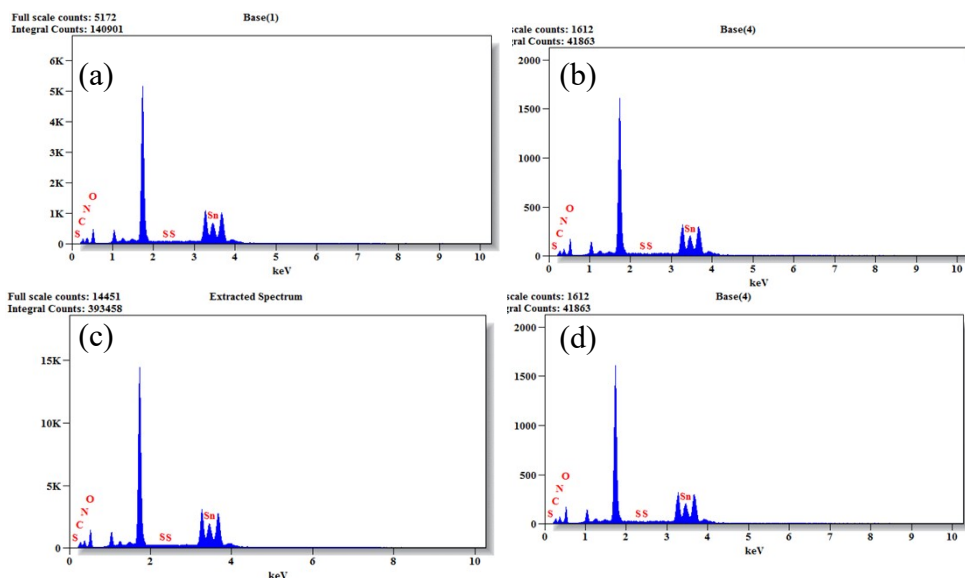


Fig. S13 EDX plot for SnO_x and AA6 passivated SnO_x films as follows. (a) SnO_x. (b) SnO_x/0.05 mg mL⁻¹ AA6. (c) SnO_x/0.1 mg mL⁻¹ AA6. (d) SnO_x/0.2 mg mL⁻¹ AA6.

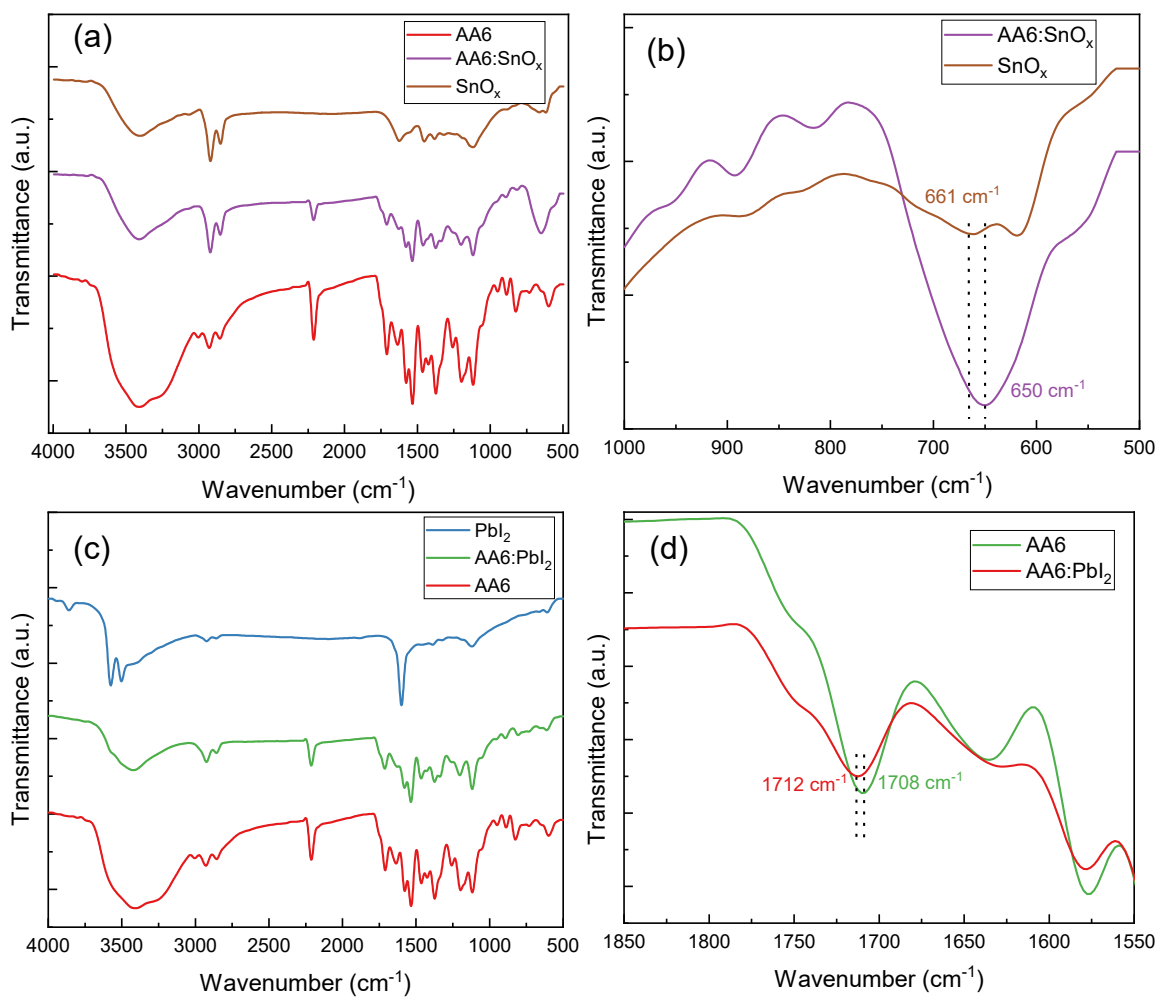


Fig. S14 FTIR spectra of (a) SnO_x, AA6 and SnO_x:AA6 mixed samples. (b) Zoomed view of Sn–O vibration peak. (c) FTIR spectra of PbI₂, AA6 and AA6:PbI₂ mixed samples. (d) Zoomed view of -C=O stretching vibration peak.

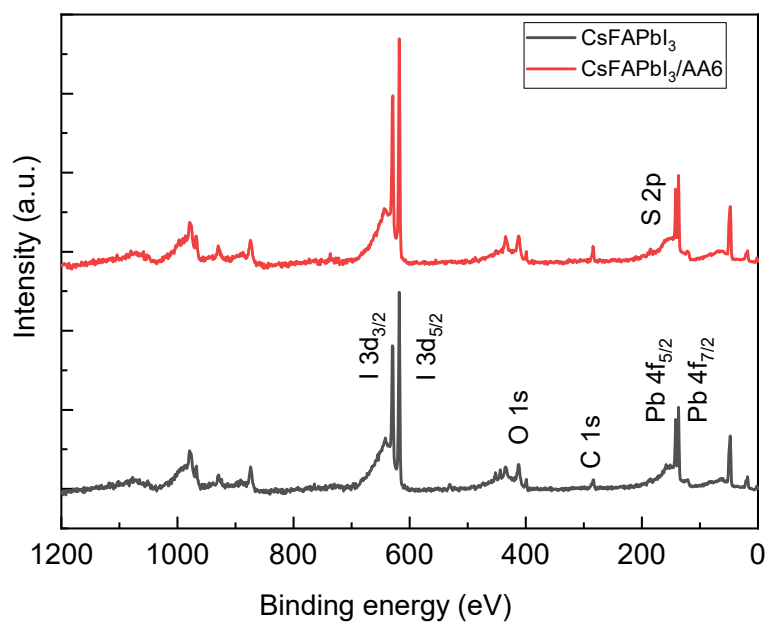


Fig. S15 XPS survey scan of CsFAPbI₃ and CsFAPbI₃/AA6 thin films.

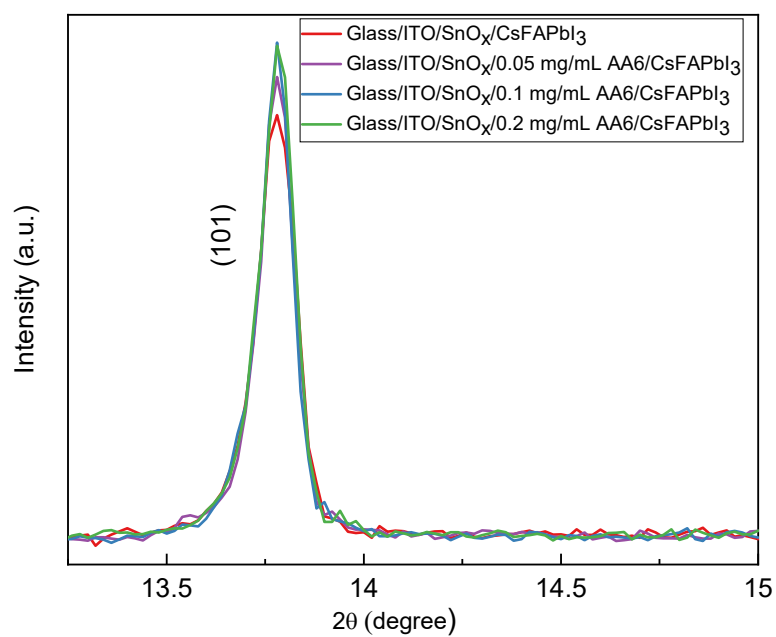


Fig. S16 XRD spectra of CsFAPbI₃ (101) plane intensity comparison.

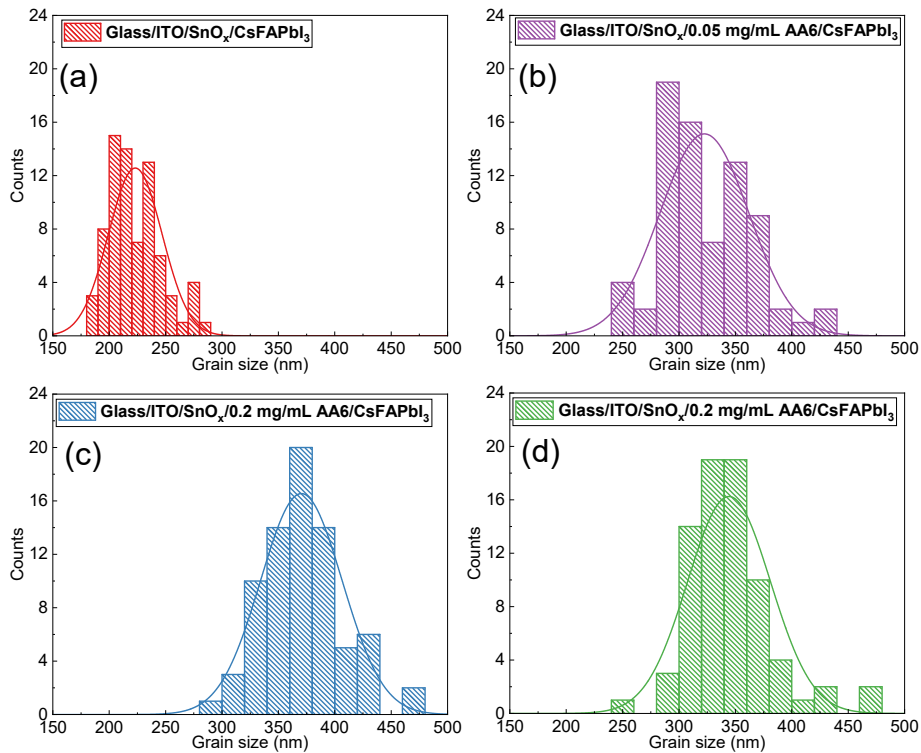


Fig. S17 (a) SEM grain size histogram plots of CsFAPb₃ and (b–d) AA6 passivated CsFAPb₃ films, grain size was calculated from ImageJ software with an average of randomly measured 75 grains.

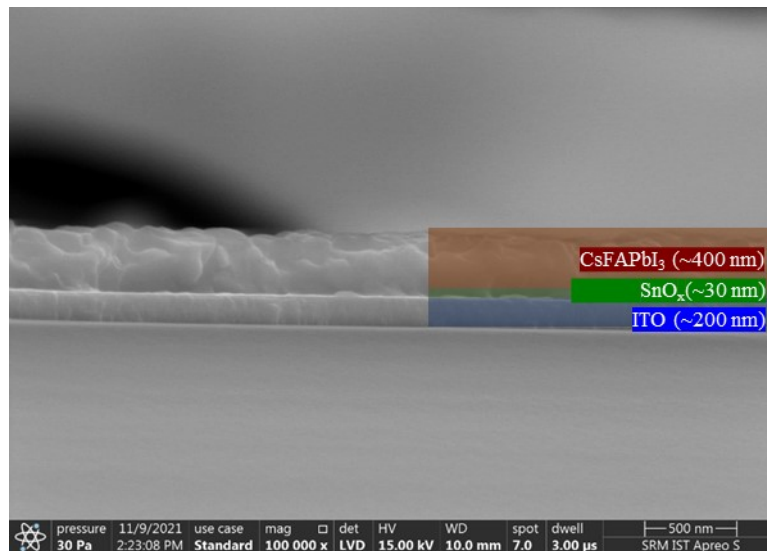


Fig. S18 Cross-section SEM of Glass/ITO/SnO_x/CsFAPb₃.

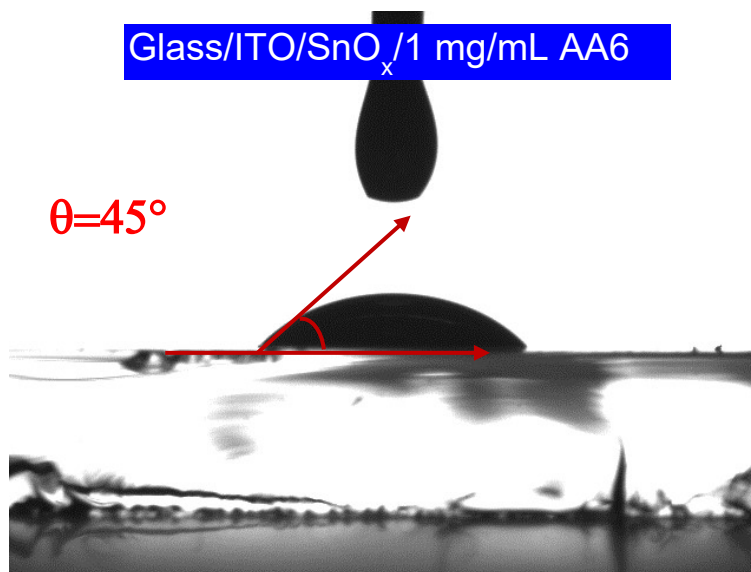


Fig. S19 Perovskite ink-based contact angle measurements for glass/ITO/SnO_x/1 mg mL⁻¹ AA6.

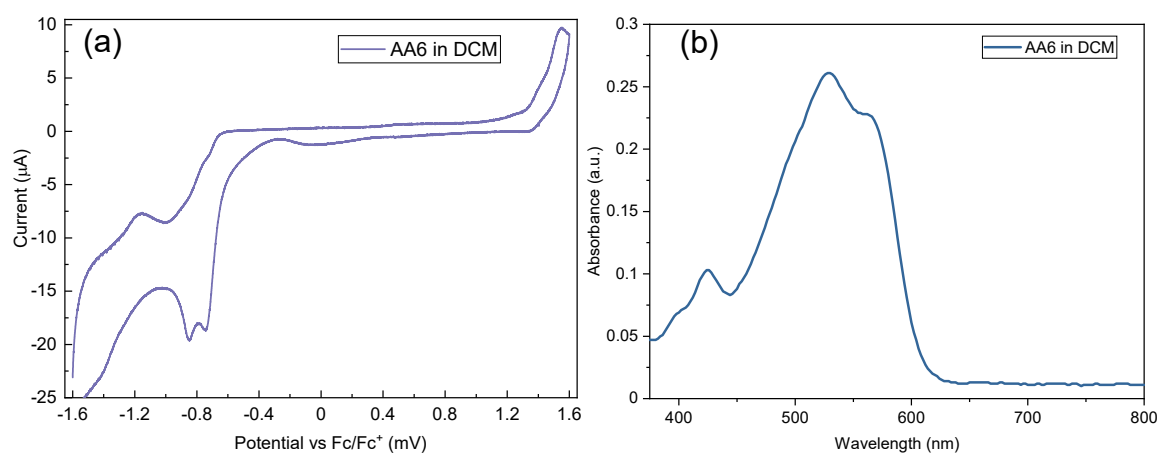


Fig. S20 (a) CV analysis of AA6 molecule (in DCM). (b) UV-Vis. spectra of AA6 molecule (in DCM).

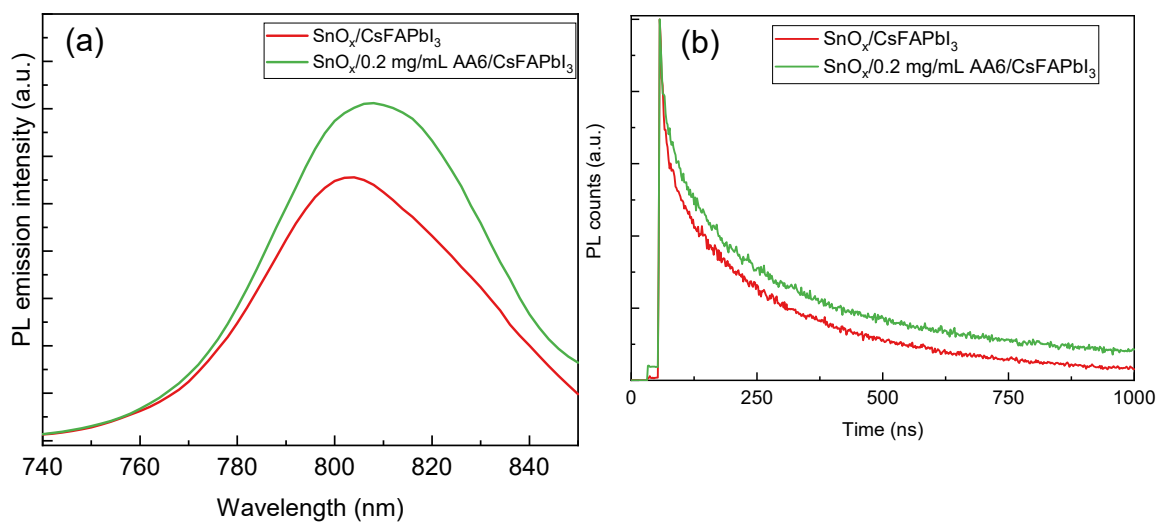


Fig. S21 (a) Steady state PL analysis of CsFAPbI_3 coated on SnO_x and 0.2 mg mL^{-1} AA6 passivated SnO_x films. (b) corresponding lifetime analysis.

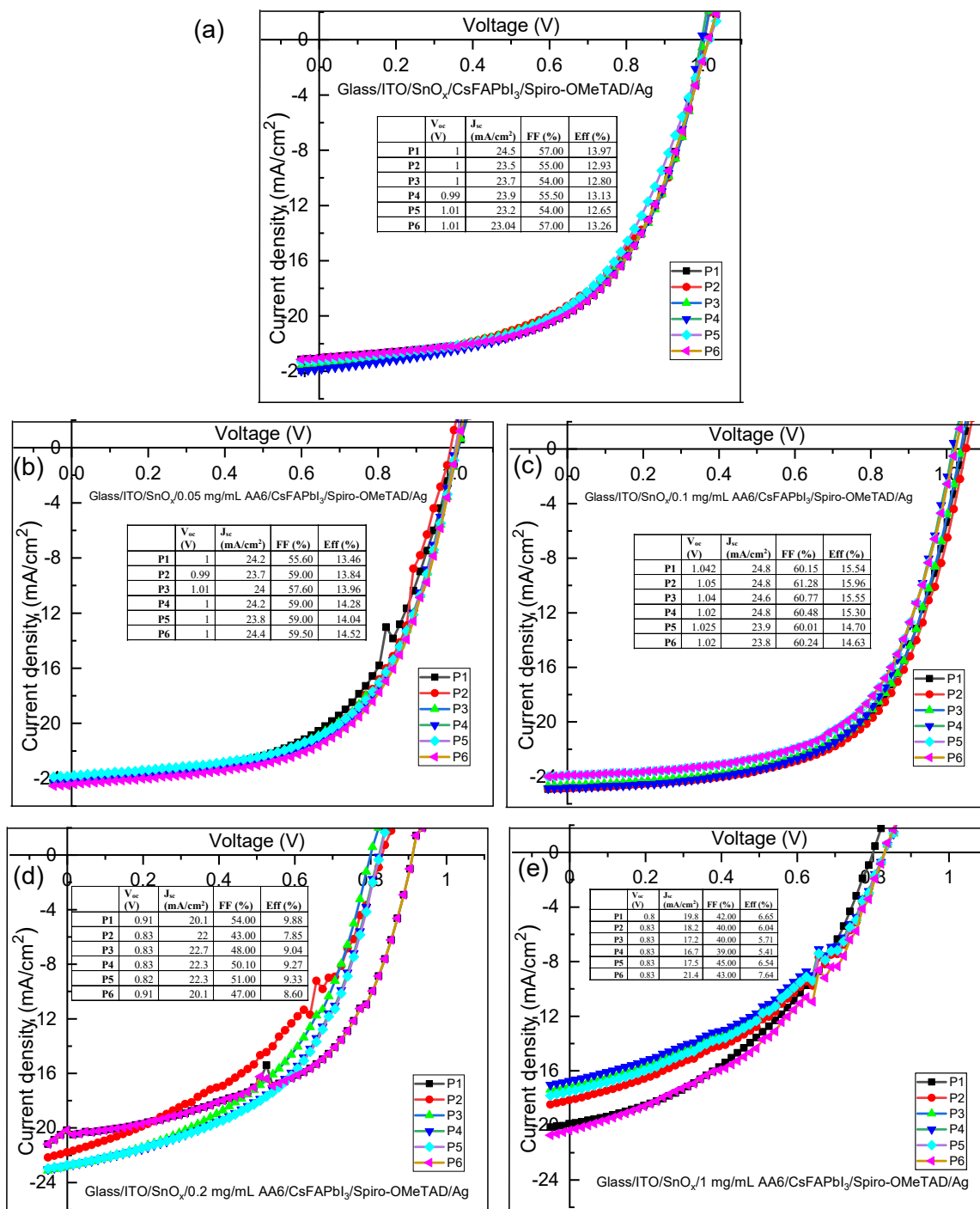


Fig. S22 Representative J-V plots of AA6 passivated PSC. (a) bare SnO_x. (b) SnO_x/0.05 mg mL⁻¹ AA6. (c) SnO_x/0.1 mg mL⁻¹ AA6. (d) SnO_x/0.2 mg mL⁻¹ AA6 and (e) SnO_x/1 mg mL⁻¹ AA6.

Table S2 Sn 3d_{5/2} peak fitting parameters of SnO_x & SnO_x/AA6.

	SnO _x	SnO _x /AA6
Sn ⁴⁺ peak [eV]	486.6	486.5
Sn ²⁺ peak [eV]	487.1	487
Sn ⁰ peak [eV]	485.8	485.4
Sn ⁴⁺ peak area	49819	36077
Sn ²⁺ peak area	13706	7256
Sn ⁰ peak area	5333	1899
Sn ⁴⁺ FWHM	1.18	1.22
Sn ²⁺ FWHM	1.74	1.81
Sn ⁰ FWHM	2	1.56
Sn ⁴⁺ percentage	72	80
Sn ²⁺ percentage	20	16
Sn ⁰ percentage	8	4

Table S3 O 1s peak fitting parameters of SnO_x & SnO_x/AA6.

	SnO _x	SnO _x /AA6
Lattice oxygen peak [eV]	530.7	530.7
Amorphous oxygen peak [eV]	532.1	532.1
Sn-O-S or Sn-O-N peak [eV]	-	532
Lattice oxygen peak area	13153	9202
Amorphous oxygen peak area	6735	3639
Sn-O-S or Sn-O-N peak area	-	913
Lattice oxygen FWHM	1.45	1.44
Amorphous oxygen FWHM	1.54	1.9
Sn-O-S or Sn-O-N FWHM	-	0.98
Lattice oxygen percentage	66	67
Amorphous oxygen percentage	33	26
Sn-O-S or Sn-O-N percentage	-	7

Table S4 TRPL lifetime parameters of CsFAPbI₃ on SnO_x and AA6 passivated SnO_x.

Samples	τ_1	I ₁	τ_2	I ₂	τ_{avg}
	(ns)	(%)	(ns)	(%)	(ns)
Glass/ITO/SnO _x /CsFAPbI ₃	65	8	305	92	301
Glass/ITO/SnO _x /0.05 mg mL ⁻¹ AA6/CsFAPbI ₃	60	9	260	91	256
Glass/ITO/SnO _x /0.1 mg mL ⁻¹ AA6/CsFAPbI ₃	25	6	180	94	179
Glass/ITO/SnO _x /0.2 mg mL ⁻¹ AA6/CsFAPbI ₃	56	6	310	94	304

* Where τ_1 and τ_2 indicate fast decay and slow decay lifetime component of perovskite absorber, I₁ and I₂ refer to corresponding amplitude and τ_{avg} represents average PL lifetime.